

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re PATENT application of: )

Hisashi OHTANI et al. ) Art Unit: 2814

Serial No. 09/550,598 ) Examiner: Unassigned

Filed: April 17, 2000 )

For: SEMICONDUCTOR DEVICE AND )

PROCESS FOR PRODUCING THE SAME )

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Commissioner for Patents, Washington, D.C. 20231, on September 20, 2001.

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents and Trademarks  
Washington, D.C. 20231

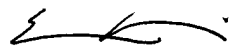
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The references listed on the attached Form PTO-1449 were cited in an Office Action for U.S. Patent Application Serial No. 09/197,767, which is the parent of the subject application.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380 (740756-2119).

Respectfully submitted,

  
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